

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

May 20, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG801665004

LABORATORY GROWN DIAMOND

ROUND BRILLIANT

6.40 - 6.44 X 3.95 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

Cut Grade

1.00 CARAT

E

VVS 2

IDEAL

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

EXCELLENT

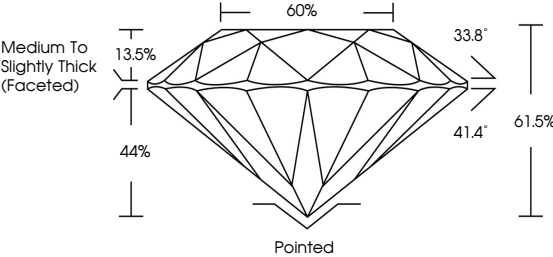
EXCELLENT

NONE

 LG801665004

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Medium To Slightly Thick (Faceted)

60%

33.8°

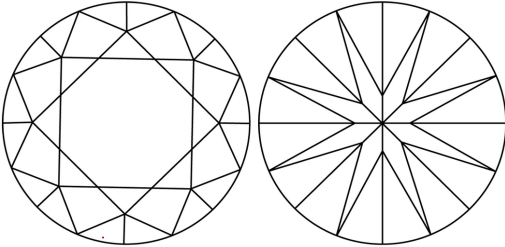
41.4°

61.5%

44%

Pointed

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

Sample Image Used



COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

FL

IF

VVS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Flawless

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included





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IGI

May 20, 2026

IGI Report No LG801665004

ROUND BRILLIANT

6.40 - 6.44 X 3.95 MM

Color Grade

Clarity Grade

Depth

Table

Girdle

Medium To Slightly Thick (Faceted)

Pointed

Polish

Symmetry

Fluorescence

Inscription(s)

1.00 CARAT

E

VVS 2

IDEAL

61.5%

66%

EXCELLENT

EXCELLENT

NONE

 LG801665004

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